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Aurion delivers systems for treatment and coating of surfaces by means of plasma processes as well as radio frequency components.

Plasma technologies employed are:

- Cleaning and activation with RIE (Reactive Ion Etching) and Microwave downstream plasma
- Coating with PVD (Physical Vapour Deposition, Sputtering) and PECVD (Plasma Enhanced Chemical Vapour Deposition)
- Activation with atmospheric plasma

Apart from systems and components Aurion offers its expertise in the area of plasma and radio frequency technology for consulting services and training.

While providing a series of standard systems for surface treatment, Aurion also develops and builds custom made systems, i.e. solutions which are tailored to the specific requirements of the customer.

Aurion's plasma systems are used in the following industrial areas:

- Semiconductor
- Medical technology
- Optics
- Automotive